#### **APS-U FORUM MEETING**



# THERMAL ANALYSIS OF HIGH HEAT LOAD MIRRORS FOR ISN BEAMLINE

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# **APS-U FEATURE BEAMLINES**

	Undulator	WB mirror	Monochromator
3Dnano	2.1 m planar 2.7 or 2.8	Yes, H	DCM, H or V
Atomic	2.1 m revolver 2.5/2.1	Yes, H	DCM/DMM, H
CHEX	Cant (1.2 m SCU 1.85, 1.65)	no	Diamond SBM, DCM
CSSI	4.6 m revolver 2.5/2.1, or planar 2.7	Yes, H	DCM&DMM
HEXM	(1.75 m SCU1.65) X2	no	Bent DLM, H
ISN 💦	4.6 m revolver 2.5/2.1	Yes, V, two	DCM/DMM
Polar	(1.8 m SCAPE SCU 3.1) X2	no	DCM, H
Ptycho	4.6 m revolver 2.5/2.1	Yes, H	DCM, H
XPCS	4.6 m revolver 2.5/2.1 or HGVPU 2.7	Yes, H, two	DCM/DMM, H



### **IN-SITU NANOPROBE** APS-U FEATURE BEAMLINE

The In-Situ nanoprobe (ISN) beamline delivers highest-resolution imaging, spectroscopy, and tomography of energy materials and energy devices, as well as of other complex, hierarchical systems under in-situ and operando conditions.

- The ISN beamline will provide a spot size as small as 20 nm using reflective optics.
- Approximately 220 m long
- Currently planned to be located at Sector 19.
- 5-30 keV
- Two Mirrors as first optics for Harmonic Rejection and bouncing back the beam. Will focus to a BDA.



# **CORRECTING FOR THERMAL BUMP**

- The thermal bump on both M1 and M2 can be corrected by bending M2. Due to the near 1:1 demagnification, bending M2 to a spherical cylinder is sufficient. The angle of M2 will need to be changed by small amounts accordingly to compensate for the vertical displacement.
- The heat load absorbed in M1 and M2 was calculated using SRCalc for Si coated mirrors. The insertion device, 25 mm period and 4.6 m long, was tuned to different energies (5-12 keV).





#### Table 1. Result summary for fixed energy operation

Photon energy		6 keV	7 keV	8 keV	9 keV	10 keV	11 keV	12 keV
$K_y$ for undulator U25		1.599	1.381	1.191	1.019	0.857	0.697	0.528
Total power absorbed by M1 (W)		329	260	190	130	80.9	44.2	20.3
Total power absorbed by M2 (W)		7.58	9.06	6.96	6.23	5.85	5.73	5.79
Focal size at BDA without deformation ( $\mu m$ ), FWHM		15.4	14.4	13.6	13.0	12.5	12.0	11.6
M2 radius to focus at BDA without deformation (km)		11.0						
Focal size at BDA with deformation $^1$ (µm), FWHM $$	1129	809	589	398	257	155	84	47
Virtual source position relative to BDA <sup>2</sup> (m)	-39.9	-47.6	-60.3	-113.9	156.1	32.8	12.1	5.6
Corrected M2 radius (km)		5.10	5.72	6.57	7.51	8.49	9.4	10.1
M2 angle correction (degree)	-1.4E-05	-1.1E-05	-9.0E-06	-7.0E-06	-5.0E-06	-3.0E-06	-5.0E-07	-1.1E-06
Corrected focal size at BDA (µm), FWHM	16.8	15.4	14.2	13.6	13.0	12.5	12.2	11.6

<sup>1</sup>M2 radius fixed at 11.0 km <sup>2</sup>Positive means downstream

The thermal bump on both M1 and M2 can be corrected by bending M2. Due to the near 1:1 demagnification, bending M2 to a spherical cylinder is sufficient.



Photon energy		5.1 keV (no correction on M2)
$K_y$ for undulator U25		1.833
Total power absorbed by M1 (W)		418
Total power absorbed by M2 (W)		10.0
Focal size at BDA with R2 = $4.38$ km optimized for 5 keV ( $\mu$ m), FWHM		21.0
Focal position relative to BDA (m)	0	-1.7

#### Table 2. Result summary for energy scan with undulator at 5 keV

• Scan energy by 100 eV at 5 keV will result in a focal size change from 17  $\mu$ m to 21  $\mu$ m at the BDA position. This will lead to some flux variation at the sample, but depends on the BDA size.





# **RAY-TRACING STUDY**

- The ray tracings below compare the ideal focus (left) with the image obtained when the deformation on M1 and M2 are included (middle).
- The figure on the right shows the focus when the radius of M2 as been decreased from the original value (11.0 km) to the value calculated (4.38 km) from the virtual image created by the heat bumps.
- Note that the angle of M2 will need to be change by 0.24 µrad to compensate for the vertical displacement





### COOLING SCHEME Internal Cooling

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- InSync Internally Cooled Mirrors. No Longer Frit Bonded
- Modeled a mirror based on their drawings
- InSync provided metrology data showing the deformation due to internal pressure







### COOLING SCHEME Side Cooled with Notch



B: Steady-State Thermal

6/13/2018 12:39 PM

**319.55 Max** 317.96

Temperature Type: Temperature

Unit: K Time: 1

Argonne

### HIGH HEAT LOAD OPTICS WORKING GROUP Jonathan Knopp and Xianbo Shi

- Discuss analysis and cooling schemes of Mirrors, Monos, Masks, Beamstops, etc.
- Discuss best practices for cooling and mounting optics
- Peter Eng will present next meeting on thermal considerations at Sector 13
- NEXT MEETING JUNE 20<sup>th</sup> AT 2:00 P.M.
  B4100



## **THANKS! QUESTIONS?**



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